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AF 1 1765



Serial No. 09/866,313

IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE

**PATENT APPLICATION**

Applicant(s): **Khan, et al.**

Case: **AM 5230**

Conf No.: **4319**

Serial No.: **09/866,313**

Filed: **May 24, 2001**

Examiner: **Deo, Duy Vu Nguyen** Group Art Unit: **1765**

Title: **METHOD OF ELIMINATING NOTCHING WHEN ANISOTROPICALLY  
ETCHING SMALL LINEWIDTH OPENINGS IN SILICON ON INSULATOR**

**ASSOCIATE POWER OF ATTORNEY**

COMMISSIONER FOR PATENTS  
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S I R:

Applicants' attorney, Donald Verplancken, hereby appoints:

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as Associate Attorneys with full powers to prosecute this application, to make alterations and amendments therein, to inspect and make copies thereof and of any papers in any appellate and inter-party proceedings in which it may be involved, and to transact all business in the United States Patent and Trademark Office connected therewith.

Please direct all correspondence relating to this application to:

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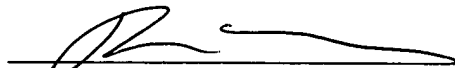
Serial No. 09/866,313

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Respectfully submitted,

12-24-03

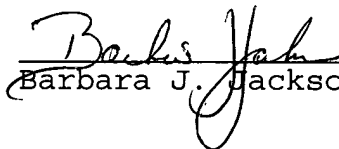
  
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**CERTIFICATE OF MAILING**

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Barbara J. Jackson